

Article

# Preparation and Optoelectronic Characteristics of ZnO/CuO-Cu<sub>2</sub>O Complex Inverse Heterostructure with GaP Buffer for Solar Cell Applications

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**Abstract:** This study reports the optoelectronic characteristics of ZnO/GaP buffer/CuO-Cu<sub>2</sub>O complex (COC) inverse heterostructure for solar cell applications. The GaP and COC layers were used as buffer and absorber in the cell structure, respectively. An energy gap widening effect and CuO whiskers were observed as the copper (Cu) layer was exerted under heat treatment for oxidation at 500 °C for 10 min, and arose from the center of the Cu<sub>2</sub>O rods. For preparation of the 30 nm-thick GaP buffer by sputtering from GaP target, as the nitrogen gas flow rate increased from 0 to 2 sccm, the transmittance edge of the spectra demonstrated a blueshift form 2.24 to 3.25 eV. Therefore, the layer can be either GaP, GaNP, or GaN by changing the flow rate of nitrogen gas.

**Keywords:** CuO whiskers; Cu<sub>2</sub>O; gallium phosphide; energy gap widen effect

### 1. Introduction

Cuprous oxide ( $Cu_2O$ ) is a potential material to replace traditional silicon and other semiconductors, being favorable because of the fabrication of cheaper solar cells for terrestrial applications, its non-toxic nature, the abundance of the starting material (copper), and cheap production processing [1–5]. The  $Cu_2O$  is intrinsically p-type, and has an energy gap (Eg) of 2.17 eV [6–8]. The p-type nitrogen-doped  $Cu_2O$  ( $Cu_2O$ :N) has an Eg of 2.5 eV owing to the energy gap widening

effect [9]. Several articles have reported on  $Cu_2O$ /transparent conductive oxide structure solar cells [8,10–12]. However, the efficiency of the  $Cu_2O$ -based solar cells is far below the maximum theoretical efficiency of 20% [7,8]. Poor minority carrier transport is a factor limiting the performance of  $Cu_2O$ -based solar cells [13–15]. Therefore, it has to introduce a buffer layer to improve the carrier collection and to optimize the cells performance. The buffer layer is a layer situated the absorber and the transparent conductive oxide. It should satisfy the following conditions: (1) a thin layer; (2) energy gap between the absorber and the transparent conductive oxide; and (3) lattice constant between the absorber and the transparent conductive oxide [16].

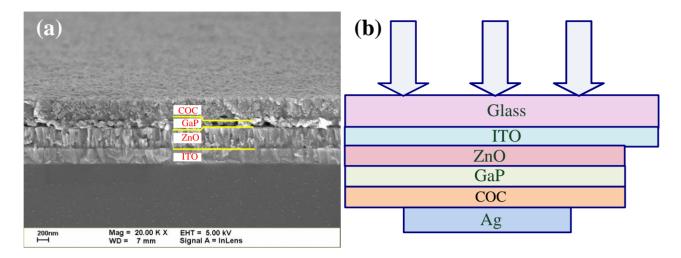
Gallium phosphide (GaP) is an indirect semiconductor and the band gap is ~2.26 eV [17–19]. The energy gap of GaP is between the absorber (CuO-Cu<sub>2</sub>O) and the transparent conductive oxide (ZnO). Therefore, this study employed GaP with ~2.26 eV absorption edge as a buffer layer in Cu<sub>2</sub>O-based solar cell. This article reports on the characteristics of Ga(N)P layers grown using magnetron reactive sputtering deposition using a GaP target. In addition, this work address a structure consisting of ZnO/GaP buffer/CuO-Cu<sub>2</sub>O complex (COC) with cascade band gap. The fabrication and optoelectronic performance of a ZnO/GaP buffer/COC inverse heterostructure solar cell are also considered.

# 2. Experimental Section

Firstly, zinc oxide (ZnO) layers were formed on an indium tin oxide-coated glass (ITO glass) substrate by magnetron reactive sputtering from ZnO targets in argon (Ar) gas at a flow rate of 15 sccm and a stable pressure of  $3 \times 10^{-3}$  Torr. Next, gallium (nitride) phosphide [a(N)P] layers were deposited onto the ZnO layer by sputtering from GaP single crystal targets in nitrogen gas at a flow rate of 0–2 sccm and Ar gas at a flow rate of 40 sccm. Sequently, one micron thick copper (Cu) layers were deposited with a purity of 99.995% onto the Ga(N)P films by sputtering from Cu targets in Ar gas at a flow of 15 sccm. The CuO-Cu<sub>2</sub>O complex (COC) films were obtained by oxidation of Cu layers annealing at various temperatures for 10 min in air ambient in a furnace. Finally, an Ag electrode was formed by sputtering onto the surface of the COC layer to complete Ag/COC/GaNP/ZnO/ITO inverse heterostructure solar cells. Figure 1 shows the cross sectional field-emission scanning electron microscopy (FESEM) images and the completed structure.

All films were prepared on glass in order to measure their electronic characteristics by Hall measurements and their absorbance and transmittance spectra. The film crystalline was studied by X-ray diffraction (XRD). An He-Cd laser (325 nm) was used as the excitation source for taking the photoluminescence (PL) measurements. Additionally, the current density-voltage (J-V) characteristics were determined using a Keithley 2420 programmable source meter under irradiation by a 100 W xenon lamp. Finally, the irradiation power density on the surface of the sample was calibrated as  $100 \text{ W/m}^2$  in order to prevent thermal radiation damaging the samples because the xenon lamp operating at  $1000 \text{ W/m}^2$  is very hot.

**Figure 1.** (a) Cross-sectional scanning electron microscopy (SEM) image of the ZnO/GaP/COC heterostructure; (b) Schematic cross section of the completed structure.



### 3. Results and Discussion

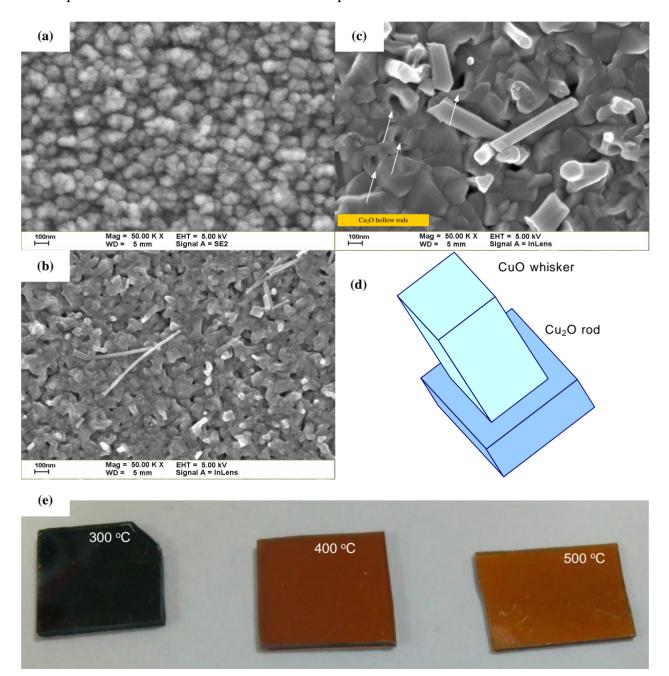
Figure 2 shows the FESEM images of the COC layers with thermal oxidation at various temperatures. The image of the COC layer with thermal treatment at 300 °C indicates that the surface of the film consisted of small particles. The average particle size was approximately 100 nm, as shown in Figure 2a. The crystal grains of COC layer were formed as oxidation temperature increase up to 400 and 500 °C, and CuO whiskers were observed, as shown in Figure 2b,c [20–22]. The CuO whiskers were extended from the center of the Cu<sub>2</sub>O rod, and the Cu<sub>2</sub>O rods were formed the hollow rods, as shown in Figure 2d. That may be attributed to CuO whiskers arising in the center of the Cu<sub>2</sub>O rods after annealing caused by the stresses between CuO and Cu<sub>2</sub>O. The CuO whiskers that were broken or collapsed during sample handling can be observed from the SEM images.

This study employed the X-ray diffraction technique to obtain the main crystalline phases and the possible orientation of crystalline in the films prepared in optimum conditions. Figure 3 shows the XRD spectrum of the measured COC films at various temperatures of 300, 400, and 500 °C. A broad diffraction peak at 36.68 °is observed for the sample with thermal treatment at oxidation temperature at 300 °C. It may be attributed to a complex layer consisted of the (-111) plane of the CuO and the (111) plane of the Cu<sub>2</sub>O. A diffraction peak at 43.81 ° caused by the residue Cu layer is also observed. With oxidation temperature increases from 400 to 500 °C, the broad diffraction peak is separated into two peaks: 36.03 ° and 36.79 °. The diffraction peak at 36.03 ° corresponding to the (-111) planes of the CuO increases and Cu<sub>2</sub>O peak decreases at 500 °C, and the Cu peak is quenched. This means that the Cu layer was completely depleted and the CuO whiskers were formed. All samples in this study are CuO-Cu<sub>2</sub>O complex layer.

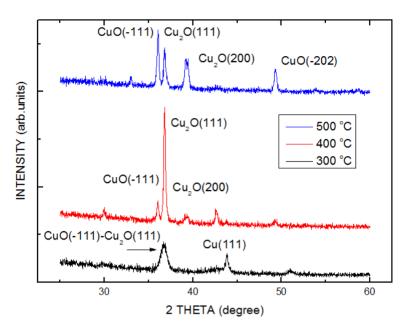
Figure 4 demonstrates the oxidation temperatures dependence of the photoluminescence (PL) spectra of the COC layers. The spectra of the COC layers include four peaks, *i.e.*, A at 2.11 eV, B at 2.15 eV, C at 2.44 eV, and D at 2.46 eV [23]. Peaks A and B are associated with the free exiton and band-to-band transition of Cu<sub>2</sub>O layers, respectively. On the other hand, peaks C and D are associated with the free exiton and band-to-band transition of Cu<sub>2</sub>O:N layers, respectively. The intensity of peaks C and D increase with oxidation temperature increasing. When the Cu layer was in the process

of oxidation in ambient air, nitrogen atoms also penetrate into the Cu layer to form the  $Cu_2O:N$  layer. The  $Cu_2O:N$  layer has a higher band gap (2.46 eV) than that of the  $Cu_2O$  layer (2.15 eV) [9]. The values of the band-to-band transition of the layers agree with Reference 9. The PL spectra of the COC layers had a broad yellow band, denoted as E at 2.29 eV. It is may be attributed to deep level caused by defects in the COC layers during oxidation. The intensity of the E band decreases with increasing oxidation temperature. This implies that there is improvement of the crystal quality of the COC layers.

**Figure 2.** (**a**–**c**) SEM images of the samples with thermal oxidation at various temperatures; (**d**) Schematic of CuO whiskers; (**e**) Optical microscopy images of the samples with thermal oxidation at various temperatures.



**Figure 3.** X-ray diffraction patterns of the COC samples with thermal oxidation at various temperatures.



**Figure 4.** PL spectra of the COC samples with thermal oxidation at various temperatures.

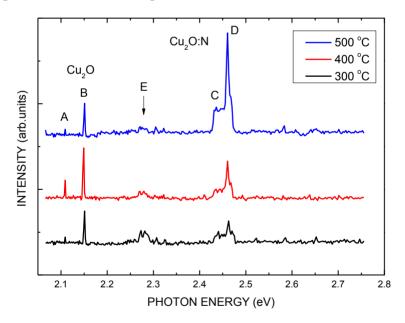
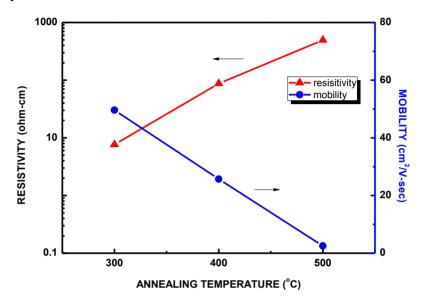


Figure 5 plots both the resistivity and the mobility of the COC layers as functions of various oxidation temperatures. As the oxidation temperature increased, the resistivity of COC layers linearly increased to 495 ohm-cm while the mobility declined to 2.5 cm<sup>2</sup>/Vs. The increasing of resistivity and the decreasing of mobility of the COC layers with increasing oxidation temperature may be attributed to the carrier scattering by the ionized acceptors [24,25]. It induced by the incorporation of nitrogen.

Sputtered GaP buffer layer with energy gap of 2.24 between the ZnO layer and the COC layer was employed in this study to improve the performance of solar cell structure. Figure 6 plots the transmittance spectra of the Ga(N)P films in the ranges 200 to 900 nm. As shown in Figure 6, the transmittance edge of spectra is to be 370, 460, and 530 nm corresponding to the nitrogen gas flow rate of 0, 1, 2 sccm as sputtering, respectively. As the nitrogen gas flow rate increases from 0 to 2 sccm, the

transmittance edge of the spectra demonstrates a blueshift. The blueshift may be attributed to the material transformation from GaP to GaN owing to phosphorous atom replaced by nitrogen atom. This can be attributed to the difference in atom radius. Phosphorous atoms have larger atomic radius (100 pm) than that of nitrogen atoms (65 pm).

**Figure 5.** The sheet resistance and the mobility as a function of thermal oxidation annealing temperatures.



**Figure 6.** Transmittance spectra of the GaP, GaNP, and GaN layers as a function of nitrogen flow rate.

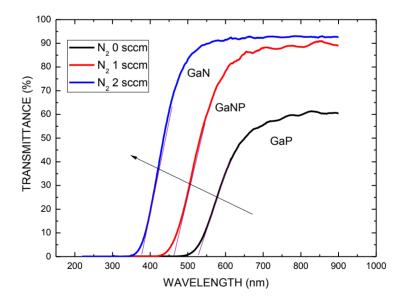
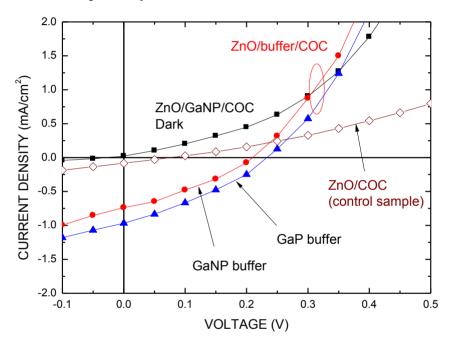


Figure 7 shows the *J-V* characteristics of the ZnO/Ga(N)P buffer/COC heterojunction with and without illumination, respectively. The *J-V* characteristics of ZnO/COC structure as the control sample are also shown, for comparison. The cell performance was measured under AM 1.5 illumination with a solar intensity of 10 mW/cm<sup>2</sup> at 25 °C. The cell has an active area of  $0.2 \times 0.4$  cm<sup>2</sup> and no antireflective coating. Table 1 presents the main characteristics of these devices in this work. As shown in Figure 7, the short current and open voltage can notably improve when the Ga(N)P buffer layer is

inserted into the structure. The GaNP has higher electron affinity than that of the GaP. Therefore, the ZnO/GaP/COC structure solar cells exhibited better performance than that of the ZnO/GaNP/COC structure in this study: short circuit current density ( $J_{\rm sc}$ ) of 0.968 mA/cm<sup>2</sup>, open circuit voltage ( $V_{\rm oc}$ ) of 0.234 V, and fill factor (FF) of 0.316. Therefore, the conversion efficiency ( $\eta$ ) can estimated to be 0.72%. The ZnO/COC structure (control sample) demonstrates a low efficiency. This may be attributed to the thermal treatment destroying the ZnO-COC interface because the COC is prone to reduction to Cu at its interface between ZnO and COC, resulting in large interface states and oxygen vacancies [26,27]. Therefore, the benefit of the buffer layer is that it protects the interface during the post-thermal treatment.

**Figure 7.** Typical J-V characteristics of the ZnO/Ga(N)P/COC heterojunction with and without illumination, respectively.



**Table 1.** The parameters of different solar cells.

Structure	$V_{\rm oc}\left(\mathbf{V}\right)$	$J_{\rm sc}~({\rm mA/cm}^2)$	FF	η (%)	$R_{\mathrm{s}}\left(\Omega\right)$	$R_{ m sh}\left(\Omega ight)$
ZnO/COC	0.077	0.083	0.250	0.016	54	_
ZnO/GaP/COC	0.234	0.968	0.316	0.720	8	61
ZnO/GaNP/COC	0.211	0.738	0.307	0.478	6	53

The series resistance  $(R_s)$  in a solar cell is a major parameter, and it is estimated by the relation:

$$\frac{dV}{dI} = R_s + \frac{nkT}{q} (I + I_{ph})^{-1} \tag{1}$$

where  $I_{ph}$  is the photocurrent, and n, k, and T are the ideality factor, Boltzmann constant, and temperature, respectively [28]. According to Figure 7, the series resistance of the control sample, the ZnO/GaP/COC structure, and the ZnO/GaNP/COC structure are 54, 8, and 6  $\Omega$ , respectively. The typical value of a silicon solar cell is around 1  $\Omega$ . In this work, the main cause of low power

conversion efficiency is high series resistance and low shunt resistance [28]. Although the series resistance is reduced by introduction of the sputtered Ga(N)P buffer layer owing to the carrier transition improvement, interconnect resistance of thw interface between the COC layer, the Ga(N)P layer, and ZnO layer is high, as shown in Figure 1a. Another factor is resistance of materials. The sputtered Ga(N)P buffer layer contains a huge oxygen atom incorporated from the sputtering system. The content in the sputtered Ga(N)P is about 0.1% measured by EDX spectrometer. On the other hand, low shunt resistance is caused by the surface states and defects in the materials. The shunt resistance  $(R_{sh})$  is estimated by the relation:

$$I = I_0 \times \left[ \exp(q \frac{V - IR_s}{nkT}) - 1 \right] + \frac{V - IR_s}{R_{sh}} - I_{ph}$$
(2)

where  $I_0$  is the saturation current [29]. The shunt resistance of the ZnO/GaP/COC structure and the ZnO/GaNP/COC structure are 61 and 53  $\Omega$ , respectively. Calculating the shunt resistance of the control sample was neglected due to high series resistance. The results are better than that of Reference 28. In order to develop a commercial thin film solar cell with high efficiency, the future is to optimize the thickness, oxidation temperature and ambient temperature of COC, the sputtering and annealing conditions of GaP and the interface between COC and GaP to suppress the surface states and defects in the cells, and to improve the quality of layers and carrier collection.

### 4. Conclusions

ZnO/GaP/COC inverse heterostructures have been prepared by the magnetron sputtering method and oxidation method. The GaP and COC films were used as a buffer and absorber in the cell structure, respectively. The band gap or absorption edge of ZnO, GaP, and COC is 3.37, 2.24, and 2.15 eV, respectively. The role of the GaP buffer layer is to provide a smooth bridge between the ZnO and the COC to improve carrier transition and reduce leakage. The measured parameters of cells were the  $J_{\rm sc}$ , the  $V_{\rm oc}$ , FF, and  $\eta$ , which had values of 0.968 mA/cm<sup>2</sup>, 0.234 V, 0.316, and 0.72%, respectively, under AM 1.5 illumination without optimum processing parameters. Therefore, as mentioned in the introduction, the GaP layer is more suitable as a buffer layer than the GaNP layer, owing to the energy gap between the ZnO layer and COC layer in the former. However, in order to develop commercial thin film solar cells with high efficiency, further work is needed. For example, the thickness of the COC layer has been shown to be very important in ZnO-COC solar cells [30]. In addition, the interface between COC and GaP also has to be studied.

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### **Conflicts of Interest**

The authors declare no conflict of interest.

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